

Notice of References Cited	Application/Control No. 10/660,920	Applicant(s)/Patent Under Reexamination ZHANG ET AL.	
	Examiner Edna Wong	Art Unit 1753	Page 1 of 1

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*	A	US-6,508,927	01-2003	Yanada et al.	205/241
	B	US-6,848,975	02-2005	Duquette et al.	451/41
	C	US-2,868,705	01-1959	BAIER JOHN J; et. al.	205/680
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	K	US-			
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*	N	JP 11117100 A	04-1999	Japan	KIKUCHI et al.	C25F 03/16
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Baumgaertner et al., "Characterization of Electropolishing Baths with Electrochemical Methods", Galvanotechnik, Vol. 86, No. 2 (no month, 1995), pp. 376-82.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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